

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Volker Härle et al.

Art Unit : 2818

Serial No. : 10/813,530

Examiner : Chuong A. Lau

Filed : March 29, 2004

Confirmation No: 5329

Title : METHOD FOR FABRICATING A SEMICONDUCTOR COMPONENT BASED
ON A NITRIDE COMPOUND SEMICONDUCTOR

MAIL STOP AMENDMENT

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

REPLY TO ACTION OF FEBRUARY 23, 2006

In reply to the Office Action of August 23, 2006, applicant submits the following
remarks: